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App. No 09/980,754 Amdt. Dated July 22, 2004 Reply to Office Action of March 22, 2004 2822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 22, 2004.

Mary Ann Copas, Secretary

In the Application of Wilfred Lerch et al

Ser.No.:

09/980,754

Filed:

February 15, 2002

For:

METHOD OF GENERATING DEFECTS IN A LATTICE STRUCTURE OF

A SEMI-CONDUCTOR MATERIAL

Art Unit:

2823

Examiner:

Julio J. Maldonado

Commissioner for Patents Alexandria VA 22313-1450

## AMENDMENT IN RESPONSE TO OFFICE ACTION DATED 03/22/04

Dear Sir:

In response to the outstanding Office Action, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

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